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	Substitute for for	m 1449B/	PTO		Complete if Known		
	INFORMATION I	DISCLO	SURE	Application Number	Unassigned		
	STATEMENT BY	Y APPLI	CANT	Filing Date	12/02/2003	· · · · · · · · · · · · · · · · · · ·	
	Date Submitted: De	ecember	2 2003	First Named Inventor	Tadahiro OHMI		
	Balo Gabrinitoa. Be		2, 2000	Group Art Unit	Unassigned		
	(use as many shee	ts as ne	cessary)	Examiner Name	Unassigned		
Sheet	1	of	1	Attorney Docket Number	039262-0115		

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Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	т⁰
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	INFORMATION	I DISCLO	SURE	Application Number	10/725,063	*
	STATEMENT 8	BY APPLI	CANT	Filing Date	12/02/2003	APP - 8
	Date Submitted	I. Anril 15	2005	First Named Inventor	Tadahiro OHMI	2005
		і, дрії то _т	2005	Group Art Unit	2826	H g
	(use as many she	ets as ne	cessary)	Examiner Name	Forde, Remmon R.	Xx A
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				(if known)			Figures Appear	<u>⊤</u>

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